

<b>Notice of References Cited</b>		Application/Control No. 10/596,755	Applicant(s)/Patent Under Reexamination OKAMOTO ET AL.	
		Examiner HUI CHIN	Art Unit 4131	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,350,807	02-2002	Blok et al.	524/493
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

#### FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 56109205 A	08-1981	Japan	TAKEUCHI et al.	C08F 36/06
	O	JP 2000044633 A	02-2000	Japan	NAKAMURA et al.	C08F136/06
	P					
	Q					
	R					
	S					
	T					

#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Translation of JP56109205, August, 1981.
	V	Translation of JP 2000044633, February, 2000.
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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